

# **Recent Results on the Measurement of Transmission and Scattering Structure on Doped and Non-doped Mirrors**

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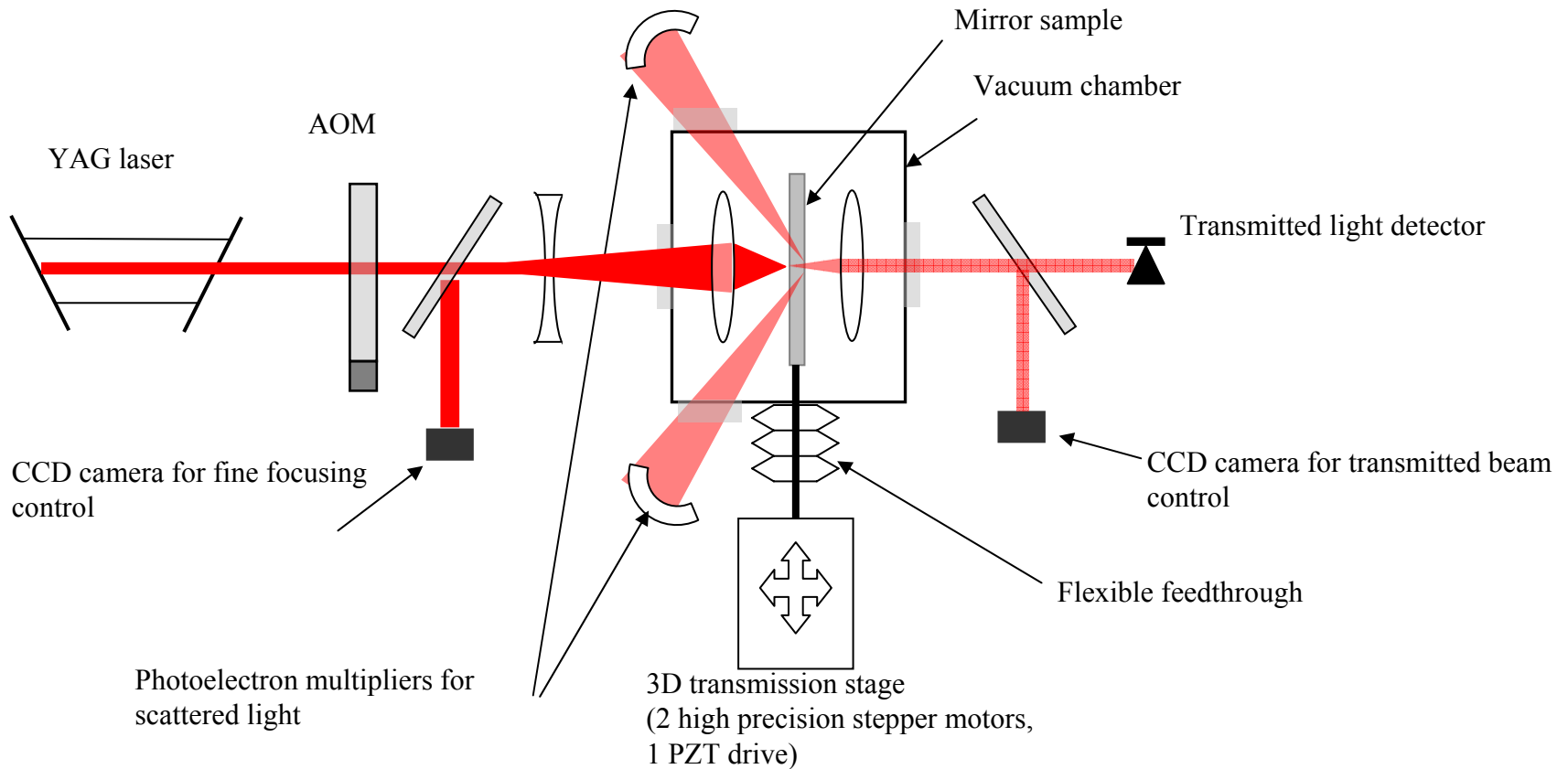
March LSC Meeting  
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# Coatings investigations: motivations and goal

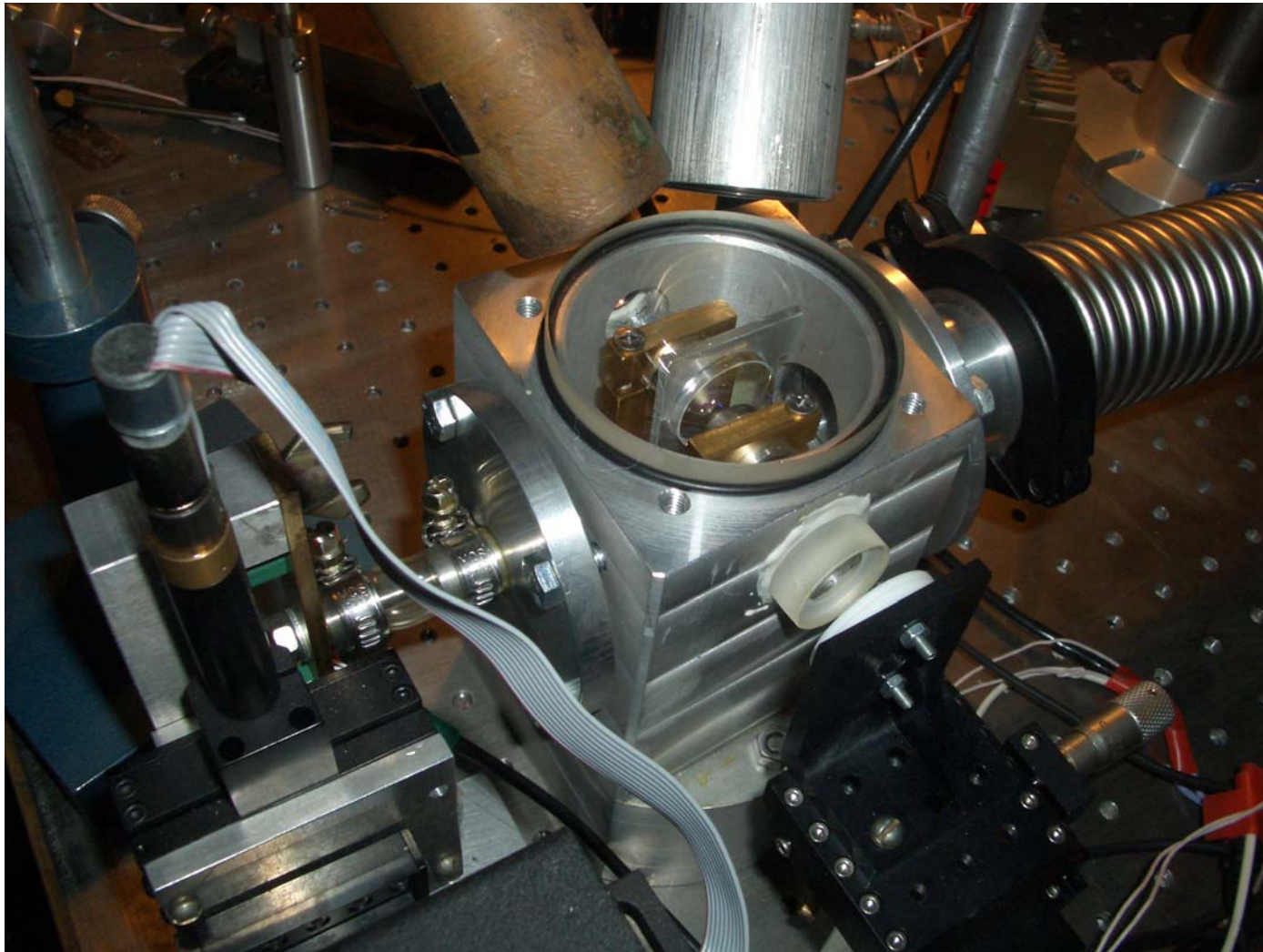


- We decided to test coatings for presence of small (starting from the size compatible to wavelength) **rare** inhomogeneities (defects).
- Such defects may not significantly contribute to the total scattering and absorption budgets nor be visible on the spatial microroughness Fourier spectra.
- Such defects may, in principle, become sources of excess mechanical noise because stress release and optical breakdown thresholds could be much lower in that points.
- Simple scanning of transmission and scattering is used as a first step before more sophisticated investigation or direct noise measurements.

# Transmission and scattering measurements setup: diagram



# Transmission and scattering measurements setup: photo



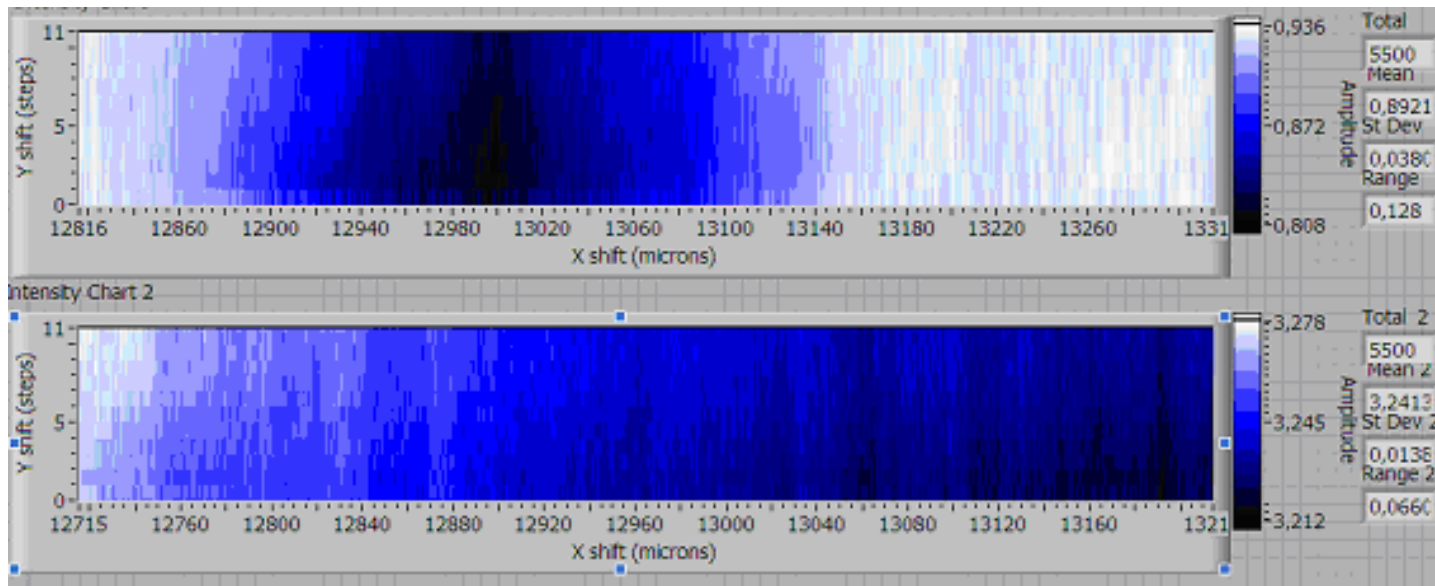


- 1  $\mu\text{m}$  spatial resolution (close to diffraction limit)
- 1-2 % transmission measurement accuracy for mirrors with  $T=10^{-4}$  (10 kHz modulation-demodulation technique is used)
- 0.5-1 % scattering variations measurement accuracy
- Power density up to 300  $\text{kW}/\text{cm}^2$
- Permanent focusing control and correction
- Approx. 5 minutes for the single  $500 \times 10 \mu\text{m}$  strip scan

# Preliminary measurements: 100 $\mu\text{m}$ plates.



Substrate: Russian  $\text{SiO}_2$ , deep polishing. Coating:  $\text{Ta}_2\text{O}_5/\text{SiO}_2$ ,  $T=5 \times 10^{-3}$   
Caltech order (REO?).

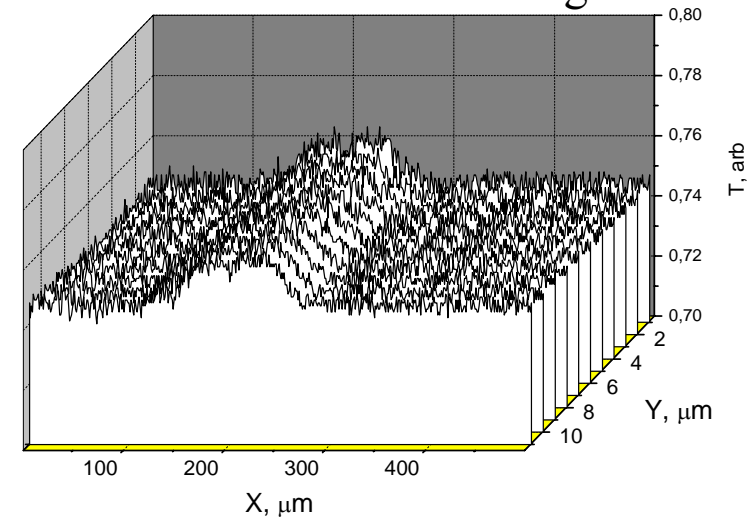


Example of the strip with a “spot” where transmission is 12% below average value (upper chart). No significant changes of scattering in this place (lower chart)

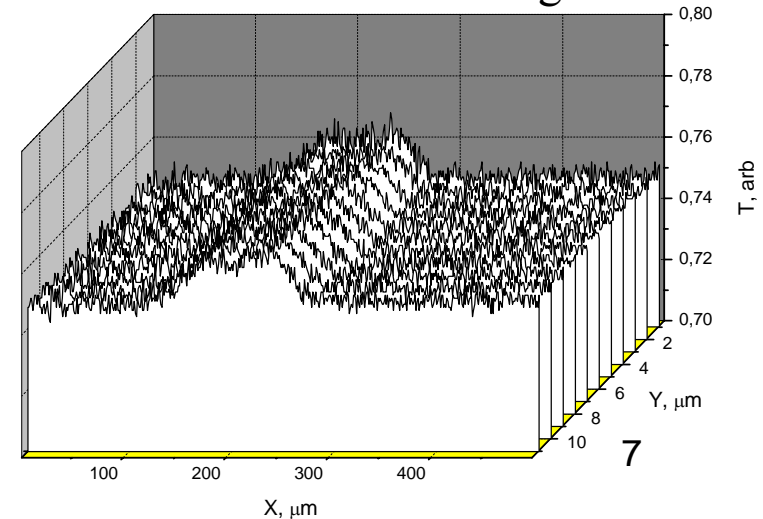


- Ultrasonic pure acetone and methanol bath has been used.
- We also tried CO<sub>2</sub> “snow” cleaner (good results, can be easily applied for the cleaning samples *in situ*)
- In order to prove that the observed “spots” aren’t a residual surface impurities, same areas were tested before and after re-cleaning. There is a good evidence that they are not (but still no 100% guarantee).
- Sometimes small (1 micron or less) very bright scattering centers disappeared after the re-cleaning: presumably dust particles.

Before re-cleaning



After re-cleaning



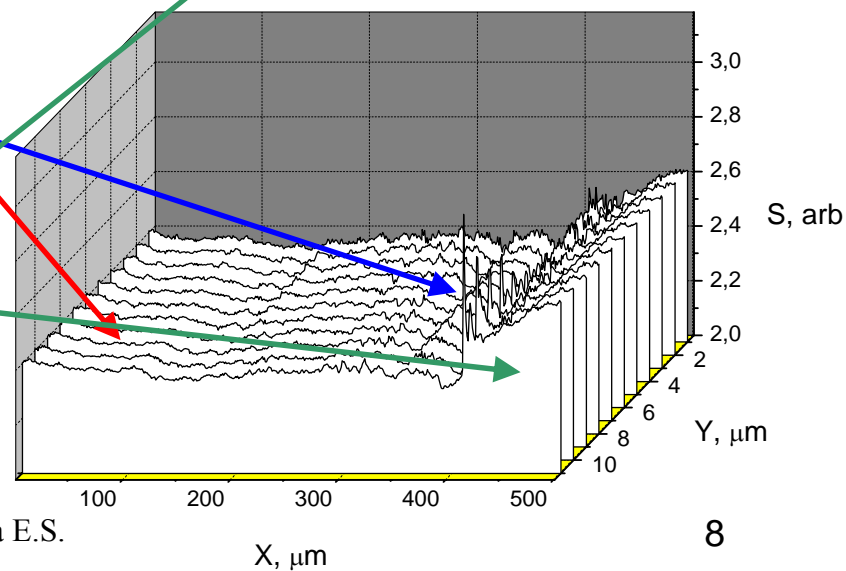
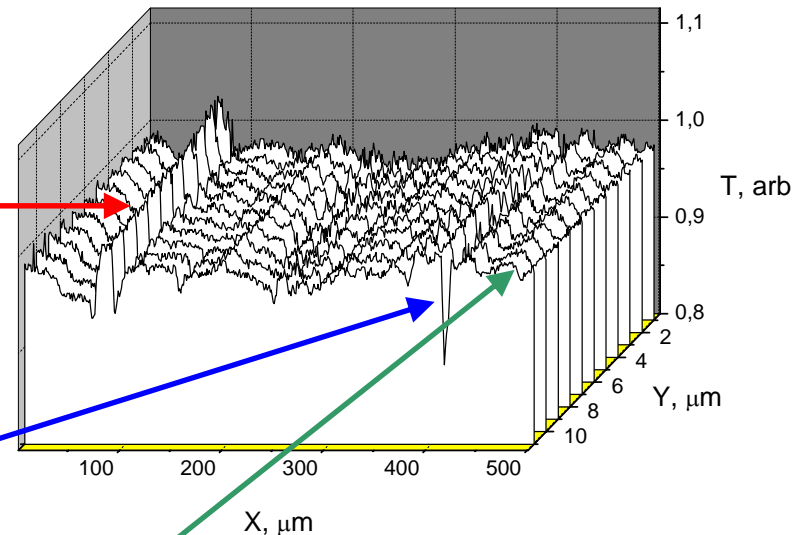
# Different types of observed defects



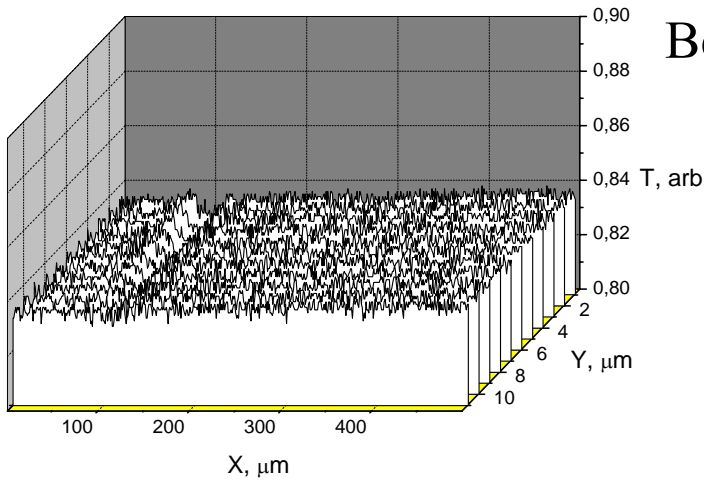
Transmission peak, no extra scattering

Transmission and scattering peaks at the same place

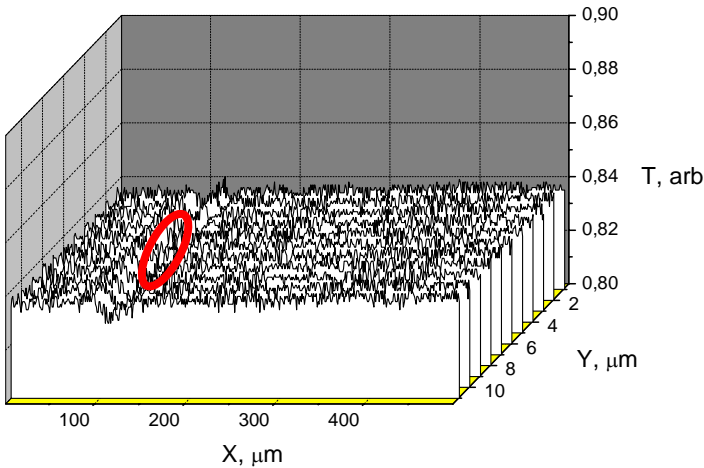
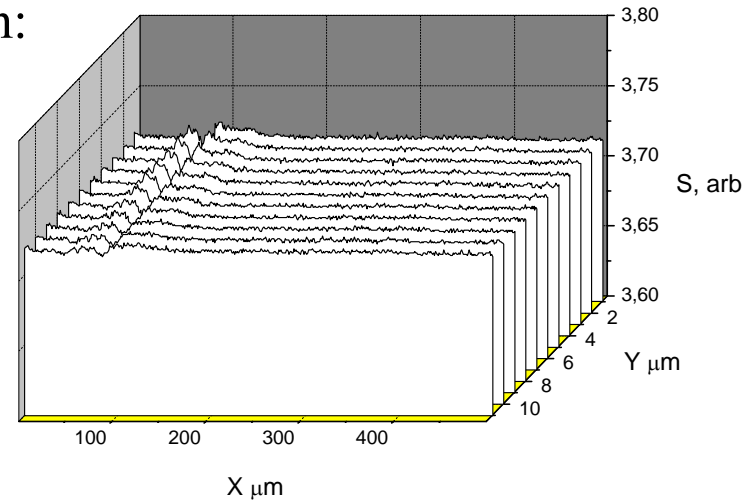
Wide scattering peak, no large transmission variation at the place



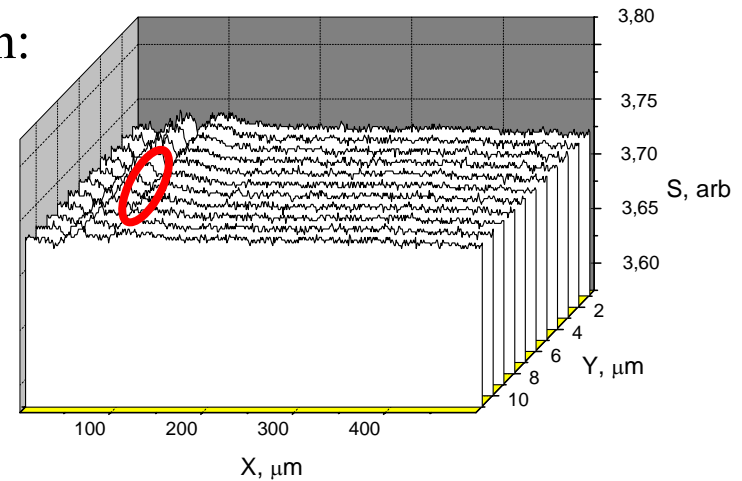




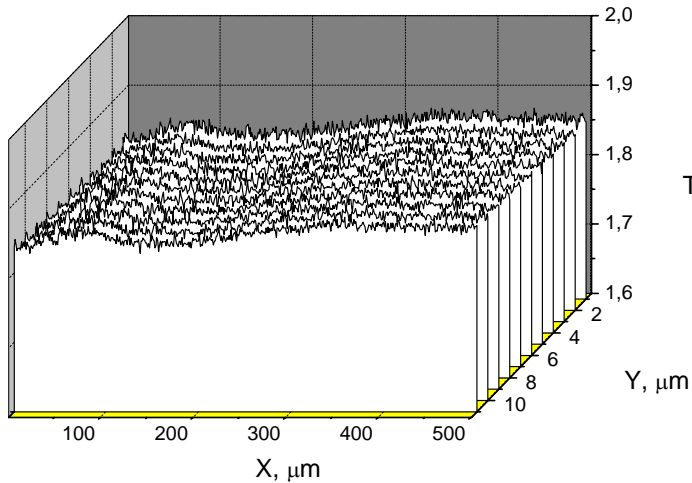
Before exposition:



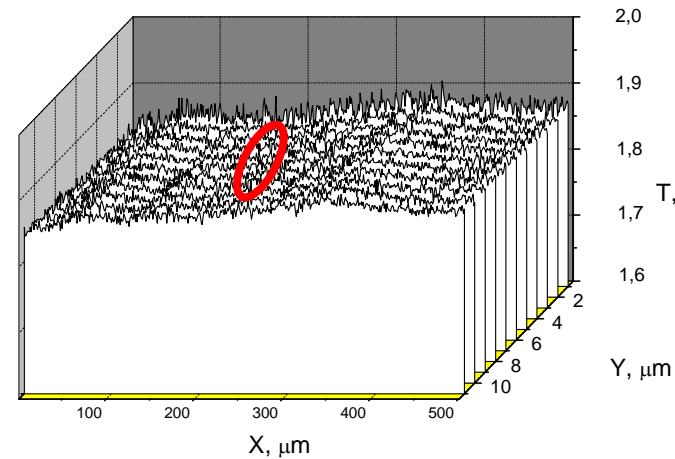
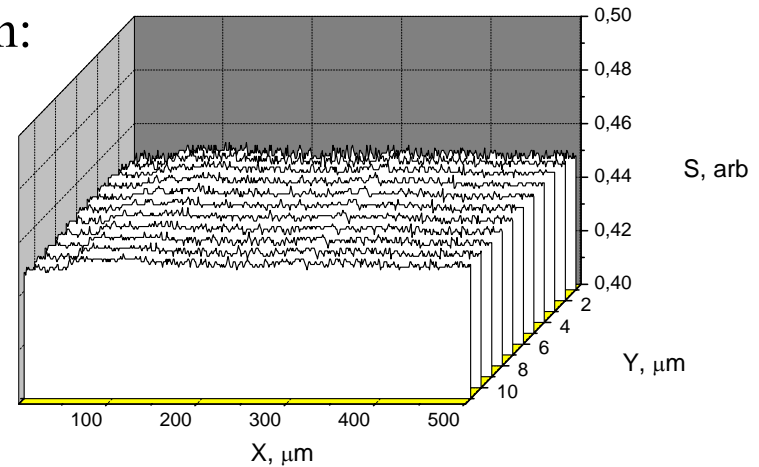
After exposition:  
 15 mW,  $5 \mu\text{m}^2$   
 ( $\sim 300 \text{ kW/cm}^2$ )  
 for 30 minutes



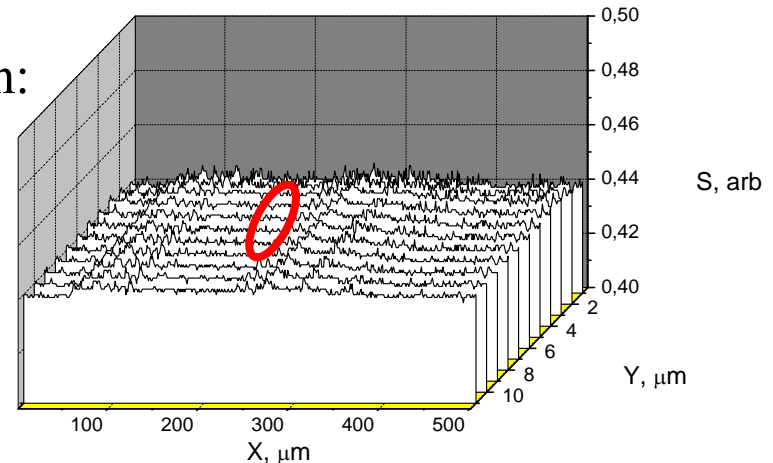
# High power density test (Ti-doped Ta<sub>2</sub>O<sub>5</sub>/SiO<sub>2</sub>: C07041121)



Before exposition:



After exposition:  
15 mW, 5 μm<sup>2</sup>  
(~300 kW/cm<sup>2</sup>)  
for 30 minutes



# Measurements summary

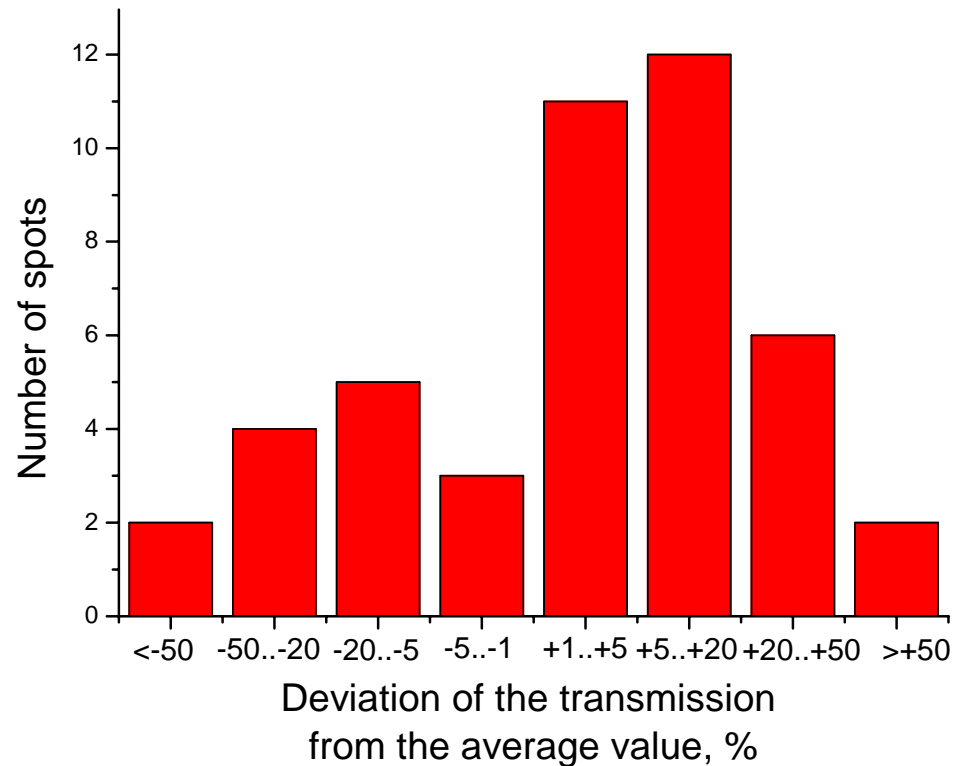


	Ta <sub>2</sub> O <sub>5</sub> /SiO <sub>2</sub> on 100 μm plate T=5x10 <sup>-3</sup>	Ta <sub>2</sub> O <sub>5</sub> /SiO <sub>2</sub> on superpolished 1" SiO <sub>2</sub> substrate. T=1x10 <sup>-4</sup> (LIGO Lab provided)	Ti-doped Ta <sub>2</sub> O <sub>5</sub> /SiO <sub>2</sub> on superpolished 0.5" SiO <sub>2</sub> substrates. T=1x10 <sup>-4</sup> (LIGO Lab provided: C07041121, C07041122)
Total scanned area	0.5 mm <sup>2</sup> (85 strips)	0.1 mm <sup>2</sup> (20 strips)	0.3 mm <sup>2</sup> (62 strips)
Number of spots observed*	81	7	18
Estimated spots area (% of scanned area)*	0.008 mm <sup>2</sup> (1.5%)	0.0006 mm <sup>2</sup> (0.6%)	0.002 mm <sup>2</sup> (0.6%)
Maximum deviation of transmittance from average value	60%	7%	30%
Maximum deviation of scattering from average value	220%	30%	90%

\* Deviation of transmittance and/or scattering from the average value exceeds 2%.



Histogram for the distribution of the spot number on the transmission value for the 100  $\mu\text{m}$  plates ( $\text{Ta}_2\text{O}_5/\text{SiO}_2$ ,  $T=5 \times 10^{-3}$  ).





Assuming that in the case when transmittance in a spot drops due to the additional adsorption, it is possible to estimate upper limit for the spot heating in AdvLIGO case:

$$\Delta T_0 = \frac{W_{ads}}{2\sqrt{\pi k_f d}} \approx 0.06 K$$

$$(W_{ads}=25 \mu W, k_f=33 W/m K, d=10^{-6} m)$$

**Observed defects seems not to be dangerous for mirrors performance ...so far.**



- Make scan area wider (80 microns instead of 10) by installation stacked PZT drive
- Reduce temperature drifts and mechanical backlash for better repeatability.
- Implement an absorption measurement (?)
- Collect more data to obtain statistically significant difference between samples (or to confirm absence of difference)
- Test another coating materials and techniques.